

Attorney Docket No. P128-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Jonathan Doan

Art Unit: Not Yet Assigned

Serial No.: Not Yet Assigned

Examiner: Not Yet Assigned

Filed: Herewith

For: **PRE-OXIDIZATION OF DEFORMABLE ELEMENTS OF MICROSTRUCTURES**

INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 CFR 1.97(b)

Commissioner for Patents
Alexandria, VA 22313-145

Sir:

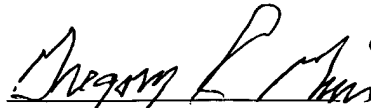
The attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached PTO Form 1449. Copies of the cited references are enclosed:

No fee or certification is required in connection with this Information Disclosure Statement, since it is being submitted prior to the last of (1) issuance of a first official action on the merits and (2) expiration of the three month period following filing of the above-captioned application.

The above information is presented so that the Patent and Trademark Office can determine any materiality thereof to the claimed invention. It is respectfully requested that the information be considered during the prosecution of this application and that the cited documents be listed on the front page of any patent issuing from this application.

The Patent Office is authorized to charge our Deposit Account No. 501516 for any fee which it deems to be required to effect consideration of this statement.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "Gregory R. Muir", written over a horizontal line.

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| INFORMATION DISCLOSURE CITATION PTO-1449 SHEET 1 OF 2 | | | ATTY. DOCKET NO. P128-US | | SERIAL NO. Not Yet Assigned | | |
| | | | APPLICANT Jonathan Doan | | | | |
| | | | FILING DATE Herewith | | GROUP Not Yet Assigned | | |
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| EXAMINER'S INITIALS | PATENT NO. | DATE | COUNTRY | CLASS | SUBCLASS | TRANSLATION | |
| | | | | | | YES | NO |
| | | | | | | <input type="checkbox"/> | <input type="checkbox"/> |
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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| INFORMATION DISCLOSURE CITATION PTO-1449 SHEET 2 OF 2 | | | ATTY. DOCKET NO. P128-US | | SERIAL NO. Not Yet Assigned | | |
| | | | APPLICANT Jonathan Doan | | | | |
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| | | | | | | <input type="checkbox"/> | <input type="checkbox"/> |
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